PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Yoshitaka Hamada	05/12/2009
Fujio Yagihashi	05/12/2009
Takeshi Asano	05/12/2009
Hideo Nakagawa	04/27/2009
Masaru Sasago	05/07/2009

RECEIVING PARTY DATA

Name:	Shin-Etsu Chemical Co., Ltd.	
Street Address:	6-1, Otemachi 2-chome	
Internal Address:	Chiyoda-ku	
City:	Tokyo	
State/Country:	JAPAN	

Name:	Panasonic Corporation
Street Address:	1006, Oaza Kadoma
Internal Address:	Kadoma-shi
City:	Osaka
State/Country:	JAPAN
Postal Code:	571-8501

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	12472681

CORRESPONDENCE DATA

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NAME OF SUBMITTER: Betty-Lou Rosser

Total Attachments: 2

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ASSIGNMENT

WHEREAS: Yoshitaka HAMADA, Fujio YAGIHASHI an Research Center, SHIN-ETSU CHEMICAL CO., LTD Niigata-ken, JAPAN (same for all of the inventors) (hereinafter referred to as ASSIGNOR), have invented and or	o., 28-1, Nishi-Fukushima, Kubiki-ku, Joetsu-shi,
Organic silicon oxide fine particles and pre	eparation method thereof, porous film- ion method thereof, and semiconductor device ed as USSN 12/472,681 filed on May 27, 2009
WHEREAS: SHIN-ETSU CHEMICAL CO., LTD., a corpor of JAPAN and having its principal place of business at 6-1, PANASONIC CORPORATION, a corporation duly organ having its principal place of business at 1006, Oaza Kadoma, (hereinafter referred to as "ASSIGNEE"), has equitable rights and to acquire all right, title and interest in and to this Patent or similar legal protection to be obtained therefor.	Otemachi 2-chome, Chiyoda-ku, Tokyo, JAPAN and ized under and pursuant to the laws of JAPAN and Kadoma-shi, Osaka 571-8501, JAPAN and to this invention and desires to confirm such
NOW, THEREFORE, in consideration of the sum of consideration, the receipt and sufficiency of which is hereby a transfers to said ASSIGNEE, its successors and assigns, including any and all United States Letters Patent which recontinuations, divisions, renewals, substitutes or reissues there Convention for the Protection of Industrial Property.	acknowledged, ASSIGNOR hereby sells, assigns, and all right, title and interest in and to said invention, may be granted therefor and any and all extensions,
ASSIGNOR hereby covenants that no assignment, sale, agreentered into which would conflict with this assignment and s	reement of encumbrance has been or will be made or ale.
ASSIGNOR further covenants and agrees, upon request, desires to carry this assignment in effect, and perfect the titl above-mentioned United States applications.	to execute any instrument which said ASSIGNEE e transferred hereby, or to file or prosecute any of the
And the Commissioner of Patents of the United States is above-named application and on any continuation, substitute	s hereby authorized to issue Letters Patent on said or division thereof to said ASSIGNEE.
IN TESTIMONY WHEREOF, I/We have hereunto set hand	and seal this 12th day of May, 2009
A GGI	CNOD.
ASSI	GNOR:
	Yoshitaka HAMADA
	Fujio YAGIHASHI Takeshi Asano
	Takeshi ASANO

ASSIGNMENT

WHEREAS: Hideo NAKAGAWA and Masaru SASAGO of c/o PANASONIC CORPORATION, 1006, Oaza
Kadoma, Kadoma-shi, Osaka 571-8501, JAPAN (same for both of the inventors)
(hereinafter referred to as ASSIGNOR), have invented and own a certain invention entitled: Organic silicon oxide fine particles and preparation method thereof, porous film- forming composition, porous film and formation method thereof, and semiconductor
device for which application for United States Letters Patent identified as USSN 12/472,681 filed on May 27, 2009 has been executed on the day of, 2009, and,
WHEREAS: SHIN-ETSU CHEMICAL CO., LTD., a corporation duly organized under and pursuant to the laws of JAPAN and having its principal place of business at 6-1, Otemachi 2-chome, Chiyoda-ku, Tokyo, JAPAN and PANASONIC CORPORATION, a corporation duly organized under and pursuant to the laws of JAPAN and having its principal place of business at 1006, Oaza Kadoma, Kadoma-shi, Osaka 571-8501, JAPAN (hereinafter referred to as "ASSIGNEE"), has equitable rights in and to this invention and desires to confirm such rights and to acquire all right, title and interest in and to this invention, including any and all United States Letters Patent or similar legal protection to be obtained therefor.
NOW, THEREFORE, in consideration of the sum of One Dollar (\$1.00) and other good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged, ASSIGNOR hereby sells, assigns, and transfers to said ASSIGNEE, its successors and assigns, all right, title and interest in and to said invention, including any and all United States Letters Patent which may be granted therefor and any and all extensions, continuations, divisions, renewals, substitutes or reissues thereof, and the right to all benefits under the International Convention for the Protection of Industrial Property.
ASSIGNOR hereby covenants that no assignment, sale, agreement of encumbrance has been or will be made or entered into which would conflict with this assignment and sale.
ASSIGNOR further covenants and agrees, upon request, to execute any instrument which said ASSIGNEE desires to carry this assignment in effect, and perfect the title transferred hereby, or to file or prosecute any of the above-mentioned United States applications.
And the Commissioner of Patents of the United States is hereby authorized to issue Letters Patent on said above-named application and on any continuation, substitute or division thereof to said ASSIGNEE.
IN TESTIMONY WHEREOF, I/We have hereunto set hand and seal this April 37, 2009 May 7th, 2009.
ASSIGNOR:
Hodes Wakasawa
Masanu Sasap
Masaru SASAGO

RECORDED: 06/03/2009